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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/622,871	07/17/2003	Masahiro Murasato	791_203 NP	2911	
25191	7590 02/04/2005		EXAM	EXAMINER	
BURR & BROWN			DOUGHERTY, THOMAS M		
PO BOX 7068 SYRACUSE, NY 13261-7068			ART UNIT	PAPER NUMBER	
			2834		
			DATE MAILED: 02/04/2009	DATE MAILED: 02/04/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)			
		10/622,871	MURASATO ET AL.			
	Office Action Summary	Examiner	Art Unit			
		Thomas M. Dougherty	2834			
	The MAILING DATE of this communication a	ppears on the cover sheet with the	correspondence address			
	or Reply		·			
THE - External after of the control	HORTENED STATUTORY PERIOD FOR REF MAILING DATE OF THIS COMMUNICATION ensions of time may be available under the provisions of 37 CFR r SIX (6) MONTHS from the mailing date of this communication. e period for reply specified above is less than thirty (30) days, a r o period for reply is specified above, the maximum statutory period ure to reply within the set or extended period for reply will, by state reply received by the Office later than three months after the mained patent term adjustment. See 37 CFR 1.704(b).	N. 1.136(a). In no event, however, may a reply be tile eply within the statutory minimum of thirty (30) day but will apply and will expire SIX (6) MONTHS from tute, cause the application to become ABANDONE	mely filed ys will be considered timely. In the mailing date of this communication. ED (35 U.S.C. § 133).			
Status						
1)🛛	Responsive to communication(s) filed on 2/1	1/05 (phone interview).				
2a)[This action is FINAL . 2b)⊠ Th	nis action is non-final.				
3)[Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.					
Disposit	tion of Claims					
4) 🛛	Claim(s) 1 and 2 is/are pending in the applic	ation.				
,—	4a) Of the above claim(s) is/are withdrawn from consideration.					
5)	Claim(s) is/are allowed.					
6)⊠	Claim(s) <u>1 and 2</u> is/are rejected.					
7)	Claim(s) is/are objected to.					
8)□	Claim(s) are subject to restriction and	/or election requirement.				
Applicat	ion Papers					
9)	The specification is objected to by the Exami	ner.				
•	The drawing(s) filed on 17 July 2003 is/are:		by the Examiner.			
	Applicant may not request that any objection to the	ne drawing(s) be held in abeyance. Se	e 37 CFR 1.85(a).			
	Replacement drawing sheet(s) including the corre	ection is required if the drawing(s) is ob	ojected to. See 37 CFR 1.121(d).			
11)	The oath or declaration is objected to by the	Examiner. Note the attached Office	Action or form PTO-152.			
Priority (under 35 U.S.C. § 119					
• —	Acknowledgment is made of a claim for foreion All b) Some * c) None of: 1. Certified copies of the priority docume	nts have been received.	, , , , ,			
	2. Certified copies of the priority docume	•				
	3. Copies of the certified copies of the pr	·	ed in this National Stage			
	application from the International Bure	, , , ,				
* (See the attached detailed Office action for a lis	st of the certified copies not receive	3 0.			
A44 - F						
Attachmen 1) Notice	nt(s) ce of References Cited (PTO-892)	4) X Interview Summary	/ (PTO-413)			
2) 🔲 Notic	ce of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail D	ate. <u>205</u> .			
	mation Disclosure Statement(s) (PTO-1449 or PTO/SB/0 er No(s)/Mail Date	5) Notice of Informal F6) Other:	Patent Application (PTO-152)			

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DETAILED ACTION

Claim Rejections - 35 USC § 103The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1 and 2 are rejected under 35 U.S.C. 103(a) as being unpatentable over Takeuchi et al. (US 6,396,196) in view of Funemi et al. (JP 2000-261283). Takeuchi et al. show (fig. 3) a piezoelectric/electrostrictive film type (1) device comprising: a substrate formed of a ceramic (see ABSTRACT), and a piezoelectric/electrostrictive operation portion (5) in which at least one piezoelectric/electrostrictive layer (5) and at least one pair of electrodes (4, 6) electrically connected to the piezoelectric/electrostrictive layer (5) are stacked on the substrate (2).

Takeuchi et al. do not note that their device includes a highly water repellent surface formed on at least one of outer surface of the piezoelectric/electrostrictive layer and an upper electrode of said at least one pair of electrodes.

Funemi et al. show (fig. 1) a piezoelectric/electrostrictive film type (1) device comprising: a piezoelectric/electrostrictive operation portion (5) in which at least one piezoelectric/electrostrictive layer (5) and at least one electrode (3) electrically connected to the piezoelectric/electrostrictive layer (5).

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Funemi et al. further show a highly water repellent surface (2) that is formed on at least one of outer surface of the piezoelectric/electrostrictive layer (5) and an upper electrode (3).

Said highly water repellent surface (2) is modified in such an extent that infiltration of moisture into micro-pores opened in at least one of the outer surface of the piezoelectric/electrostrictive layer (5) and the upper electrode (3), and/or into a gap between the substrate and the piezoelectric/electrostrictive layer (5) is sufficiently inhibited.

Funemi et al. do not show at least two electrodes in a stack configuration with their piezoelectric/electrostrictive substrate. It is unknown whether or not their substrate is a ceramic material specifically.

It would have been obvious to one having ordinary skill in the art to employ the highly water repellent surface of Funemi et al., which is modified so that infiltration of moisture into micro-pores opened in the outer surface of the piezoelectric/electrostrictive layer or into gaps between the substrate and the piezoelectric/electrostrictive layer is sufficiently inhibited, forming it on the outer surface of at least the piezoelectric/electrostrictive layer or the upper electrode, in the device of Takeuchi et al. in order to provide a device superior in resistance to stresses caused by use and weather, as noted by Funemi et al. Such a design would lengthen the lifetime of the device, thereby reducing replacement costs.

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Direct inquiry to Examiner Dougherty at (571) 272-2022.

And tmd

February 1, 2005

TOM DOUGHERTY PRIMARY EXAMINER

ThomasM. Lougher